Vertex Detector for the CEPC

A Prospective Overview

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Outline

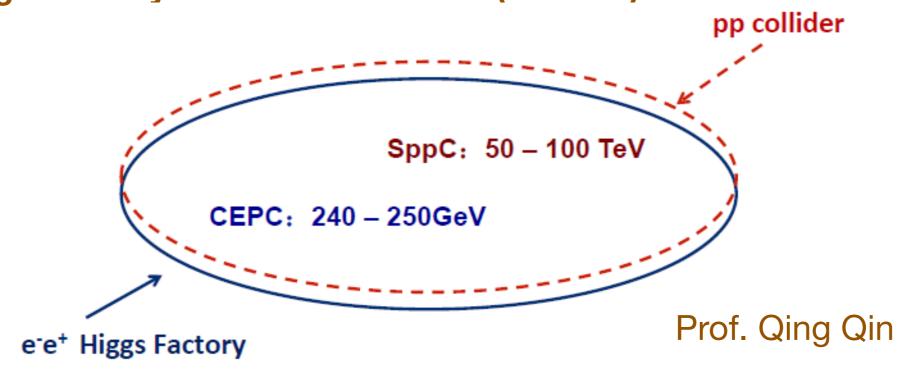
- Introduction to CEPC
- Performance requirements
- Candidate technologies
- R&D status
- Summary

Introduction

 The Higgs Discovery in 2012 witnessed the breakthrough in the history of particle physics and triggered wave of thoughts on Higgs Factories around the world ...

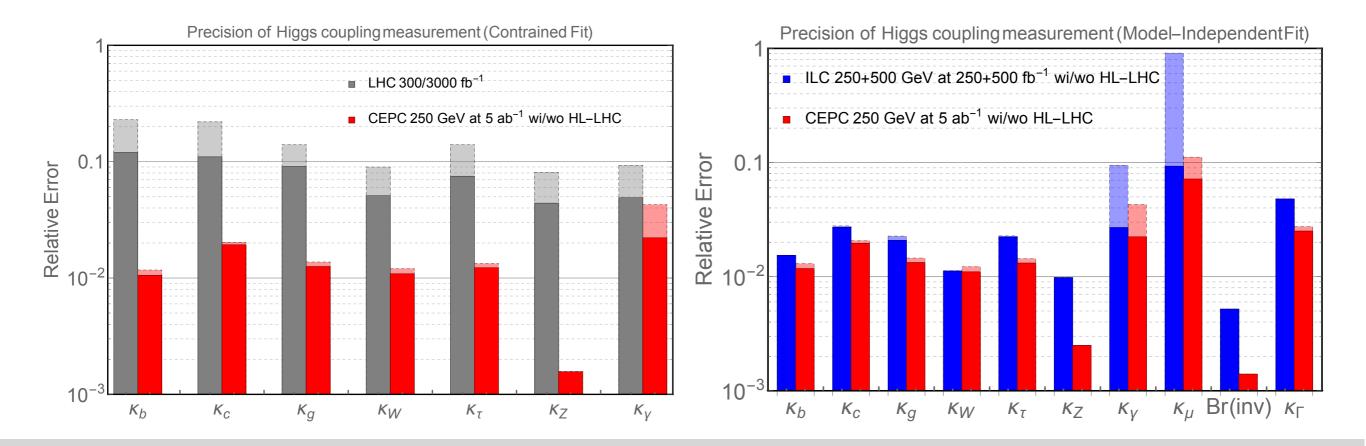
A. Bondel and F. Zimmerman, A High Luminosity e+e- Collider in the LHC tunnel to study the Higgs Boson, arXiv:1112.2518, even before the Higgs discovery!

 Where the story began ... presented by Prof. Qing Qin at the Accelerators for a Higgs Factory: Linear vs. Circular (HF2012)



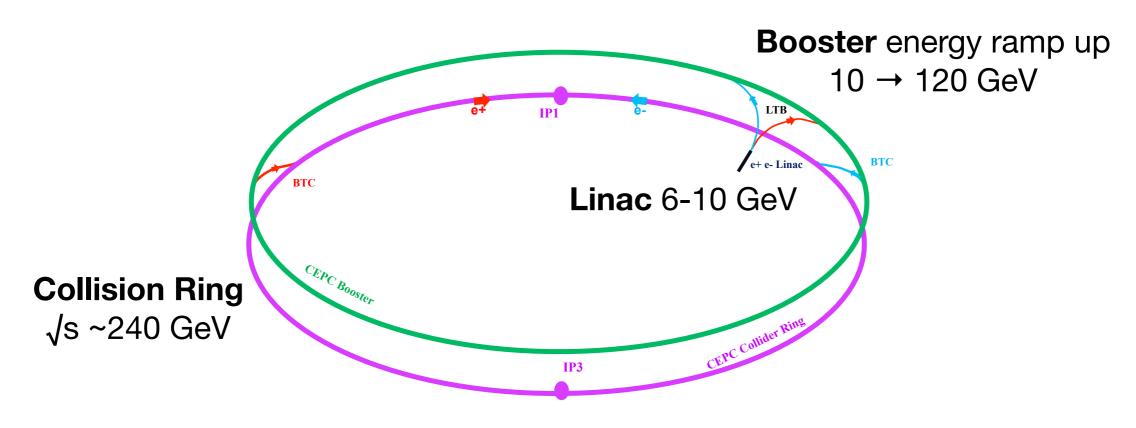
Circular Electron Positron Collider

- Circular Electron Positron Collider (CEPC) to collide electron/positron beams at √s ~240 GeV with a peak luminosity of 2×10³⁴ cm⁻²s⁻¹, and 2 IP to deliver ~1M clean ZH events over 10 years → Higgs Factory
 - Higgs mass, cross section, branching ratios, couplings etc.
- Operate at Z-pole/WW threshold → EW precision measurements



Possible Project Timeline



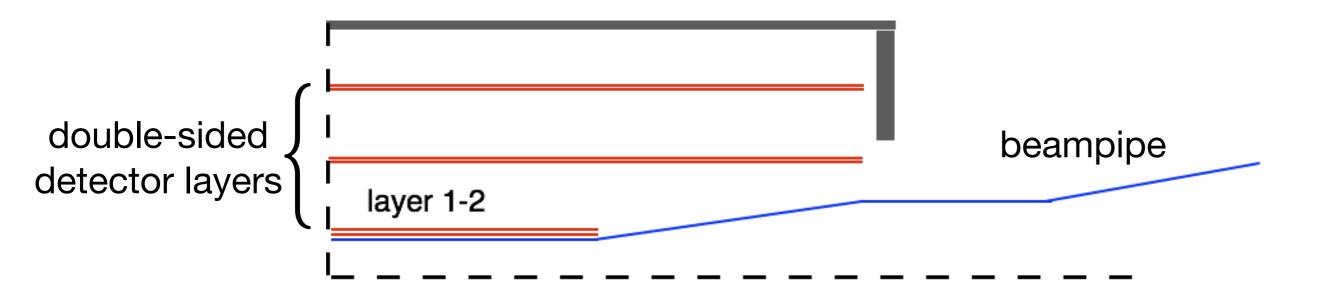


Vertex Detector

 Crucial to achieve high impact parameter resolution, which is required for heavy flavour (b/c) and τ-tagging:

$$\sigma_{r\phi} = 5 \oplus 10/p \cdot \sin^{3/2}\theta \ \mu \text{m}$$

• For the physics feasibility studies, the ILD vertex detector layout has been adopted, which features 3 double-sided layers ranging between 1.6 -6.0 cm



Performance Requirements

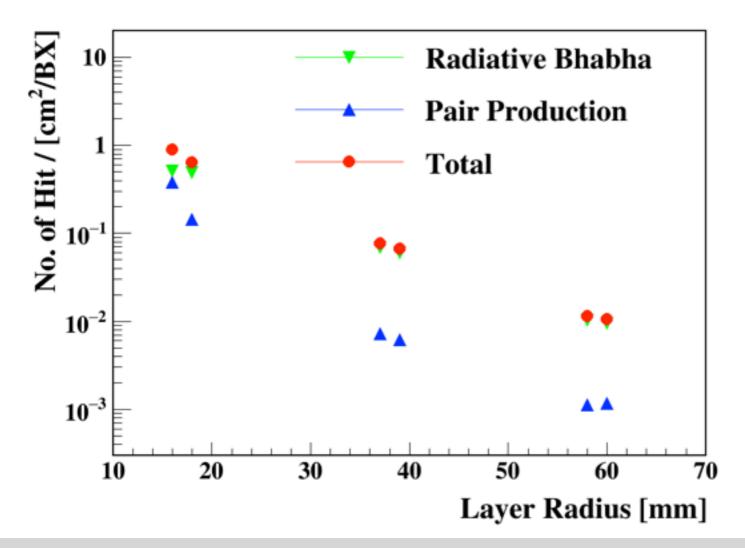
$$\sigma_{r\phi} = 5 \oplus 10/p \cdot \sin^{3/2}\theta \ \mu \text{m}$$

- Imposing stringent requirements on the Vertex detector
 - Spatial resolution near the interaction point σ_{SP} ≤3 μm → high granularity (small pixel size)
 - Material budget ≤0.15%X₀/layer → monolithic pixel sensor (sensor + embedded electronics, thinned down to e.g. 50 μm) + air cooling (power dissipation ≤50 mW/cm²)
 - Low detector occupancy below 0.5% → high granularity and short integration time
 - ► Radiation tolerance (pre.): ~1 MRad (TID) and 10¹² n_{eq}/cm² (NIEL)

Similar to the ILC vertex detector requirements but without power-pulsing

Hit Density

- Critical parameter to determine the segmentation (+ physics requirements) and readout time of pixel sensors
- Mostly driven by background events originating from pair production, radiative Bhabha scattering, synchrotron radiation ...



bunch spacing ~ 3.6 µs

Layout Optimisation

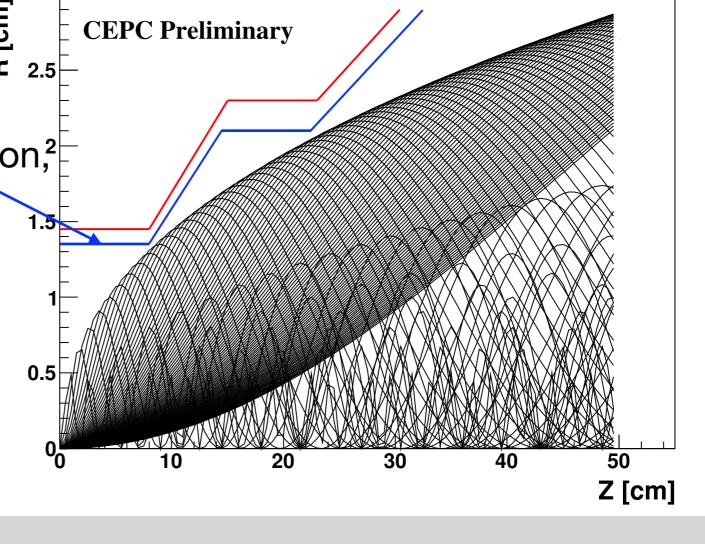
 The 1st vertex detector layer as close as possible to IP to minimise the extrapolation uncertainty and to improve the impact parameter resolution

 Electrons/positrons from pair production will develop a "kinematic edge" and detector components and beampipe should be kept sufficiently far

away from this edge.

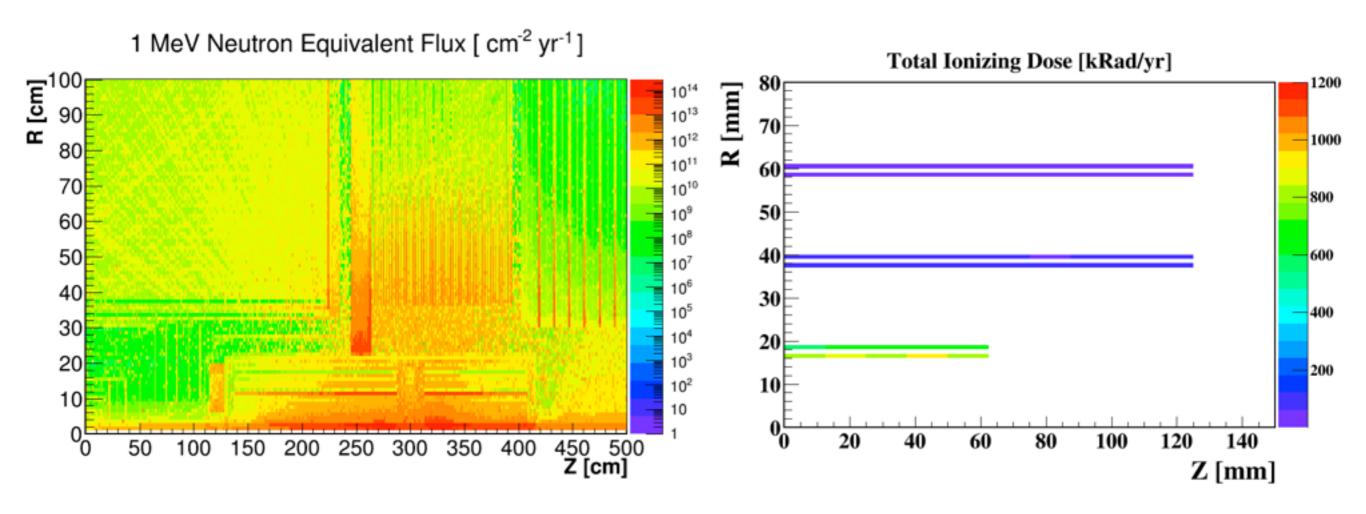
possible to push the beampipe closer by 1 mm in the central region,² and exact gain to be estimated

general strategy for layout optimisation being developed



Radiation Levels

Benign radiation environment by the (HL-)LHC standard, but still considerable



Annual values (including safety factors of 5):

NIEL: 10¹² n_{eq}/cm² and TID: 1 MRad

Candidate Technologies

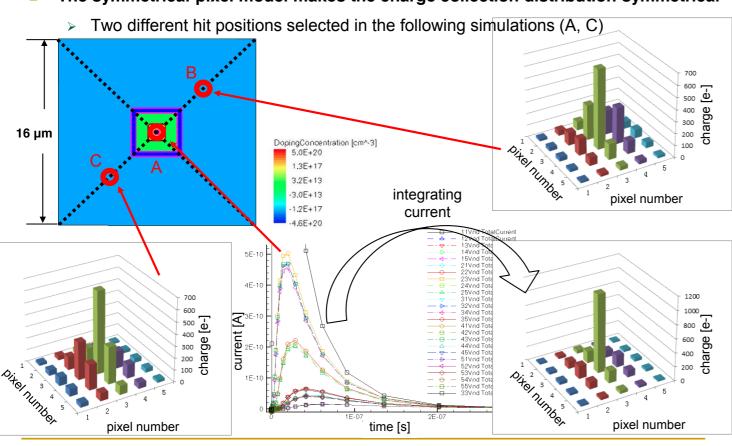
- Monolithic pixel sensor technologies considered:
 - CMOS: Ultimate installed for STAR PXL, technology for ALICE ITS upgrade, pursued by ATLAS for Pixel Phase-II upgrade ...
 - DEPFET: Belle-II pixel detector (attractive feature of self-supporting structure with low material budget in the active volume)
 - SOI: actively pursued for X-ray detection (existing design expertise, see Yunpeng Lu's talk), potential issue with radiation tolerance
 - ▶ 3D-IC: trials within the 3D consortium, promising (ultimate detector) but technology not mature enough
- Given the technology maturity and accessibility, CMOS technology (
 TJ CIS 0.18 µm) has been chosen for initial sensor R&D.

Early Stage R&D

 Important to understand the charge collection efficiency with different diode geometries, epitaxial layer resistivity and thickness, radiation damage ... ,
 TCAD simulation followed by measurements → sensor optimisation

Charge collection vs. hit position

The symmetrical pixel model makes the charge collection distribution symmetrical



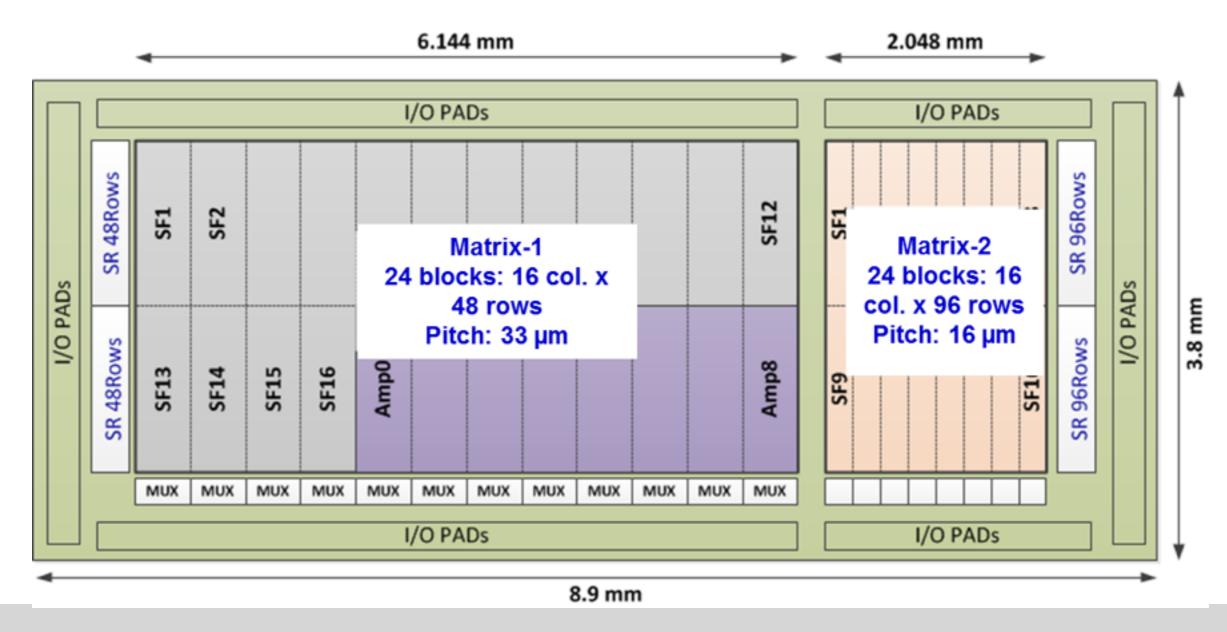
Sector	Diode area	Footprint	Structure
SFB1	3 μm ²	20 μm ²	2T_nmos
SFB2	$4 \ \mu m^2$	$20\;\mu m^2$	2T_nmos
SFB3	8 μm²	$20\;\mu\text{m}^2$	2T_nmos
SFB4	$3 \mu m^2$	$15 \ \mu m^2$	2T_nmos
SFB5	$4 \mu m^2$	$15 \ \mu m^2$	2T_nmos
SFB6	$8 \ \mu m^2$	$15 \ \mu m^2$	2T_nmos
SFB7	$3 \mu m^2$	$11~\mu m^2$	2T_nmos
SFB8	$4~\mu m^2$	$11~\mu m^2$	2T_nmos
SFB9	$8 \mu m^2$	11 μm ²	2T_nmos
SFB10	$3 \mu m^2$	$8 \mu m^2$	2T_nmos
SFB11	$4 \mu m^2$	$8 \mu m^2$	2T_nmos
SFB12	$8 \mu m^2$	$8 \mu m^2$	2T_nmos
SFB13	8 μm²	$20~\mu m^2$	2T_pmos
SFB14	$4 \mu m^2$	$8 \mu m^2$	2T_pmos
SFB15	8 μm ²	20 μm ²	3T_nmos
SFB16	4 μm ²	8 μm²	3T nmos

See Ying Zhang's talk

26 September, 2015, HSTD10

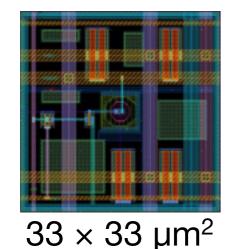
First Submission

 Submission mainly for charge collection optimisation, but with several blocks reserved for analog circuit studies (e.g. amplifiers)

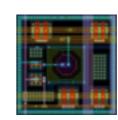


Considerations

Pixel sizes of 16 × 16 μm² (binary readout) and 33 × 33 μm² (multi-bit ADC) to achieve 3μm resolution with conmtratints: 1. power consumption, 2.) effective area → possible alleviation with extension in z (z resolution loss to be studied with physics simulation) or 3D-IC (analog/digital tiers)



areas filled up with capacitors possible for implanting more transistors



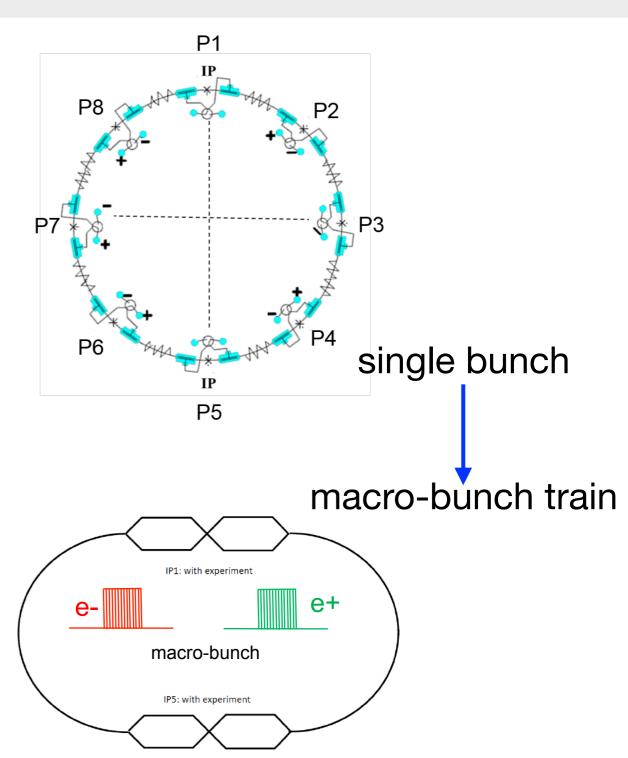
completely filled up

 $16 \times 16 \ \mu m^2$

- Readout architecture: digitisation in pixel (to minimise power dissipation to drive analog signal) and sparsified readout → e.g. ALPIDE for the ALICE ITS
- Cooling technique: force-air cooling demonstrated for STAR PXL and thermal simulation for CLIC vertex detector, or more aggressive with micro channel cooling (LHCb)

Moving Target

- As the accelerator design evolves, the requirements on the vertex detector might have to change.
- Increased backgrounds would lead to in higher radiation tolerance requirement and time-stamping capability (O(10ns)) to distinguish bunch crossings.
- Necessary to revise the sensor specifications and readout requirements in near future.



Summary

- Circular Electron Positron Collider (CEPC) as a Higgs Factory → precision
 Higgs measurements
- Performance requirements on the vertex detector similar to that of the ILD but with special considerations on power consumption and backgrounds → might have to be revised
- Pixel sensor R&D based on CMOS technology has just started with sensor charge collection optimisation

Thank you for your attention!

Luminosity

